

10/579487

Attorney's Docket No.: 14603-020US1 / P2003,0802 US N

AP20 Rec'd PTO 16 MAY 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Othmar Leitner, et al.      Art Unit : Unknown  
Serial No. : N/A      Examiner : Unknown  
Filed : Herewith  
Title : METHOD FOR THE PRODUCTION OF TRANSISTOR STRUCTURES WITH  
LDD

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450


INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form. Under 37 C.F.R. § 1.98 (a)(2)(ii), only copies of foreign patent documents and/or non-patent literature are enclosed. Copies of any listed U.S. patents or U.S. patent application publications can be provided upon request.

This statement is being filed with the application. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: May 16, 2006

  
\_\_\_\_\_  
Paul A. Pysher  
Reg. No. 40,780

Fish & Richardson P.C.  
225 Franklin Street  
Boston, MA 02110  
Telephone: (617) 542-5070  
Facsimile: (617) 542-8906

21332422.doc

CERTIFICATE OF MAILING BY EXPRESS MAIL

Express Mail Label No. EL 980079253 US

May 16, 2006  
Date of Deposit

Substitute Form PTO-1449 (Modified)  <b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)  (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 14603-020US1	Application No. <b>10/579487</b>
	Applicant Othmar Leitner, et al.		
	Filing Date	Group Art Unit	

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	5,538,909	07/23/1996	Chen-Chung Hsu			
	AB	6,010,936	01/04/2000	Jeong-Hwan Son			
	AC	2002/003290	01/10/2002	Tatsuru Namatame et al			
	AD	6,040,602	03/21/2000	H. James Fulford			
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL	05343674	12/24/1993	Japan- Abstract only				
	AM	07094714	04/07/1995	Japan- Abstract only				
	AN	07142728	06/02/1995	Japan- Abstract only				
	AO	04368133	12/21/1992	Japan- Abstract only				
	AP	11111979	04/23/1999	Japan- Abstract only				
	AQ	61226968	10/08/1986	Japan- Abstract only				

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AR	
	AS	
	AT	
	AU	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	